Notice of References Cited Application/Control No. 10/791,459 Examiner Jermele M. Hollington Applicant(s)/Patent Under Reexamination SHENG ET AL. Art Unit Page 1 of 1

U.S. PATENT DOCUMENTS

*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Name	Classification
	Α	US-5,119,337 A	06-1992	Shimizu et al.	365/201
	В	US-5,406,212 A	04-1995	Hashinaga et al.	324/760
	С	US-5,844,429 A	12-1998	Cho, Sung Ho	327/68
	D	US-6,037,792 A	03-2000	McClure, David Charles	324/760
	E	US-6,100,751 A	08-2000	De et al.	327/534
	F	US-6,104,061 A	08-2000	Forbes et al.	257/330
	G	US-6,114,866 A	09-2000	Matsuo et al.	324/760
	Н	US-6,157,201 A	12-2000	Leung, Jr., Arthur T.	324/760
	ı	US-6,137,301 A	10-2000	Chen, Chung-Zen	324/760
	J	US-6,218,892 B1	04-2001	Soumyanath et al.	327/537
	К	US-6,262,588 B1	07-2001	Chen, Chung-Zen	324/765
	L	US-6,310,485 B1	10-2001	McClure, David Charles	324/760
	М	US-			

FOREIGN PATENT DOCUMENTS

*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Country	Name	Classification
	N					
	0					
	Р					
	ø					
	R					
	S					
	Т					

NON-PATENT DOCUMENTS

*		Include as applicable: Author, Title Date, Publisher, Edition or Volume, Pertinent Pages)
	U	
	V	
	w	
	x	

^{*}A copy of this reference is not being furnished with this Office action. (See MPEP § 707.05(a).) Dates in MM-YYYY format are publication dates. Classifications may be US or foreign.